

10/565653

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OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Koichi
Family Name::	KANAYA
City of Residence::	Nishishirakawa-gun
Country of Residence::	Japan

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Toru
Family Name::	OTSUKA
City of Residence::	Nishishirakawa-gun
Country of Residence::	Japan

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Takao
Family Name::	KANNO
City of Residence::	Nishishirakawa-gun
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	VAPOR DEPOSITION APPARATUS AND VAPOR DEPOSITION METHOD

Attorney Docket Number:: 126247
Suggested Drawing Figure:: 2
Total Drawing Sheets:: 3
Small Entity:: No

Representative Information

Attorneys associated with Customer No. 25944.

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP2004/006007	04/26/04
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-284912	08/01/03	Yes
Assignee Information			
Assignee Name::	Shin-Etsu Handotai Co., Ltd.		
Street of mailing address::	4-2, Marunouchi 1-chome		
City of mailing address::	Chiyoda-ku		
State or Province of mailing address::	Tokyo		
Country of mailing address::	Japan		
Postal or Zip Code of mailing address::	100-0005		